

Notice of References Cited		Application/Control No.	Applicant(s)/Patent Under Reexamination	
		10/813,929	KAYUKAWA, HISASHI	
Examiner		Art Unit		Page 1 of 1
John Rivell		3753		

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-1,649,321 A	11-1927	OVERLANDER, JACOB ALPHEUS	137/223
*	B	US-1,917,499 A	07-1933	CONRAD, WILLIAM T	137/234.5
*	C	US-3,207,172 A	09-1965	STEER, DONALD E; et. al.	137/234.5
*	D	US-3,334,650 A	08-1967	STEWART, JR JOSEPH T; et. al.	137/375
*	E	US-3,561,467 A	02-1971	Lutz, Sepp	137/234.5
*	F	US-4,462,449 A	07-1984	Zabel, Jr., John H.	137/234.5
*	G	US-5,172,720 A	12-1992	Richards, Donald L.	137/454.5
*	H	US-6,050,295 A	04-2000	Meisinger et al.	137/541
*	I	US-6,719,003 B2	04-2004	Schroeder et al.	137/234.5
J	US-				
K	US-				
L	US-				
M	US-				

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.